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Dated: 10/10/05 Signature: Eileen Sheffield
(Eileen Sheffield)

Docket No.: NY-RPP-202
(10510421)
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
BECKMANN

Application No.:

Group Art Unit: N/A

Filed:

Examiner: Not Yet Assigned

For: HIGH FREQUENCY PLASMA JET SOURCE
AND METHOD FOR IRRADIATING A
SURFACE

PRELIMINARY AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

Prior to prosecution on the merits, please amend the above-identified patent application as follows: